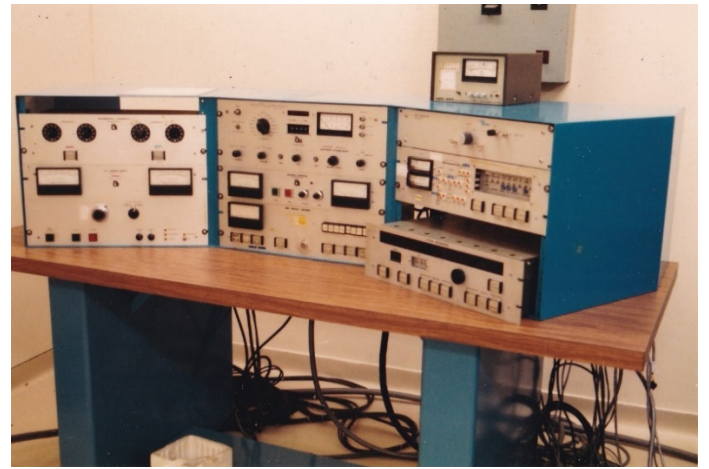
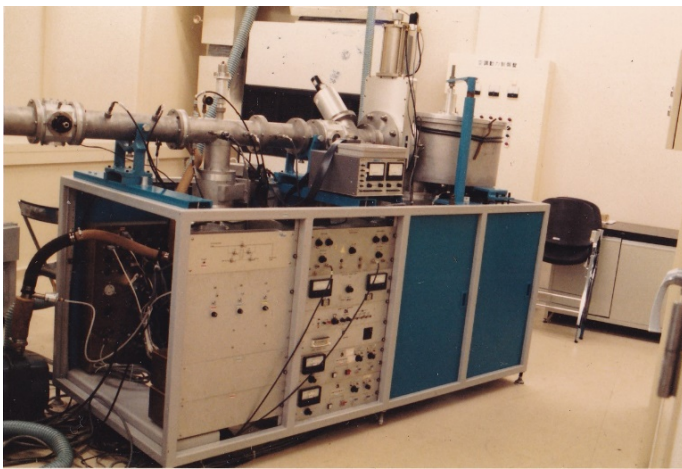
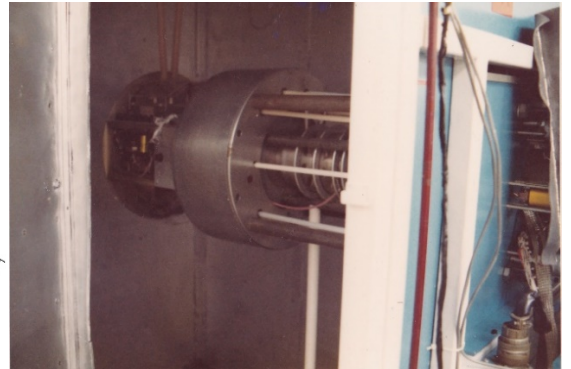
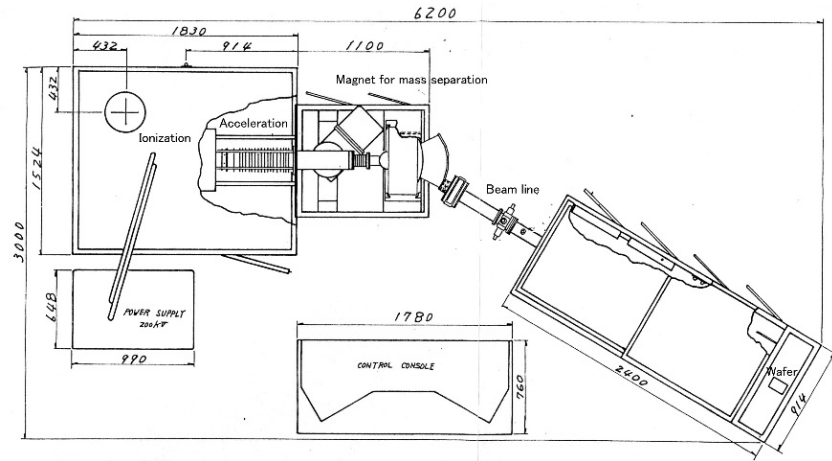
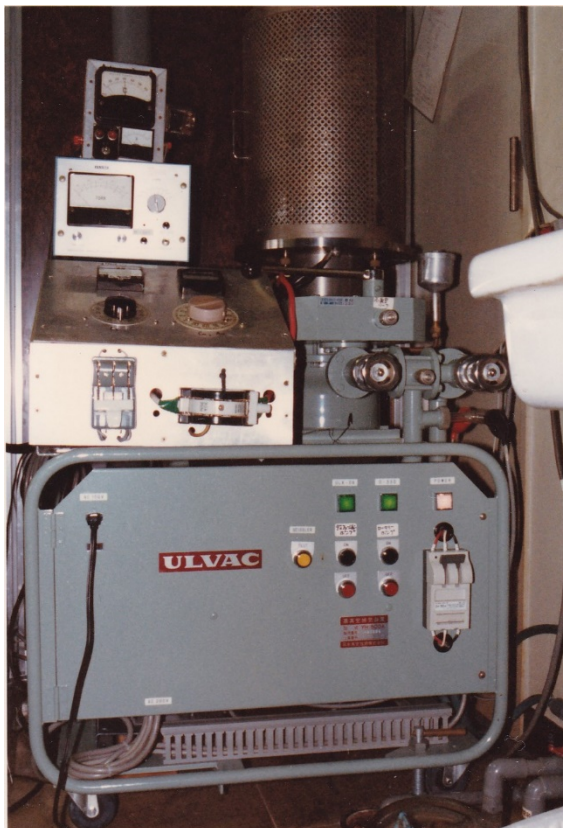


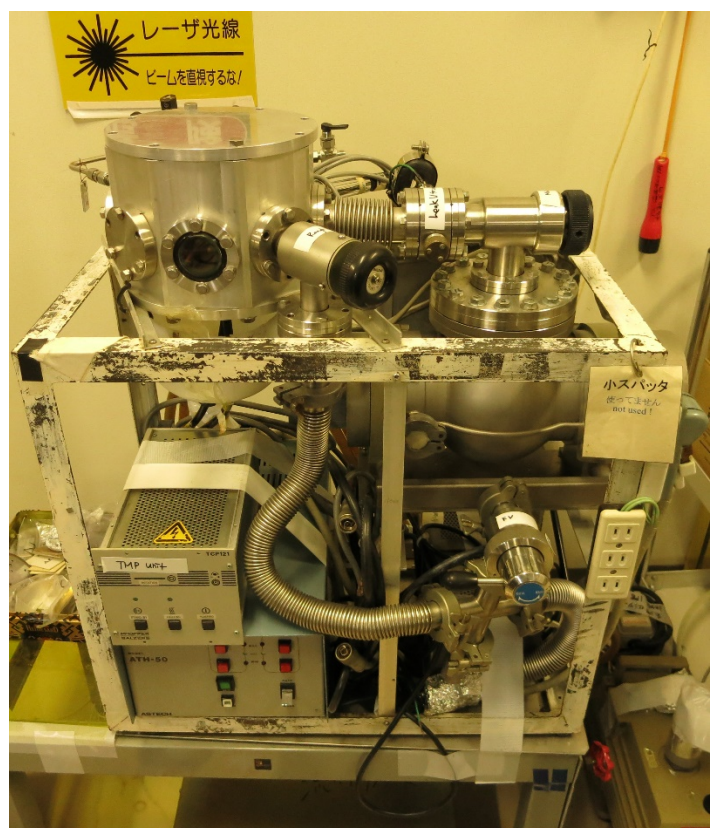
6 Wafer process (3) ion implantation, sputtering



Ion implanter (Accelerator Inc, 200MP second hand)



Al, Cr-Cu-Au evaporator



Magnetron sputter deposition